

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Masahiko HATA et al.

New 371 Application

Filed: Herewith, April 24, 2006

Attorney Docket No.: 7372/88130

Confirmation No. Not Yet Assigned

Customer No.: 42798

For: METHOD FOR MANUFACTURING COMPOUND SEMICONDUCTOR SUBSTRATE

**GENERAL AUTHORIZATION FOR PETITION FOR  
EXTENSION OF TIME UNDER 37 C.F.R. §1.136(a)(3)**

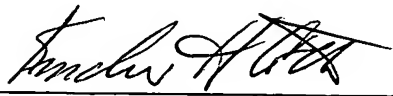
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Randolph Building  
401 Dulany Street  
Alexandria, VA 22314

Sir:

Applicant(s) hereby request under 37 C.F.R. §1.136(a)(3) by this general authorization that any concurrent or future reply submitted by Applicant(s) to the United States Patent and Trademark Office for the above-identified patent application requiring a petition for an extension of time under §1.136(a) for its timely submission be treated as incorporating therein a petition for an extension of time for the appropriate length of time.

If Applicant(s) do not timely pay for any extension fee(s) pursuant to 37 C.F.R. §1.136(a) which may become due for this application under 37 C.F.R. §1.17 by check, the Commissioner is hereby authorized to charge such fee(s), and any additional fees which may be required in this application under 37 C.F.R. §§1.16-1.17 during its entire pendency, or credit any overpayment, to Deposit Account No. 06-1135.

Date: April 24, 2006

  
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